

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>PTGF-03064</b>		Application Number <b>10/529,254</b>	
				Applicant(s) <b>Takemasa Yasukawa</b>			
				Filing Date <b>March 25, 2005</b>		Group Art Unit <b>2823</b>	
<b>PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/B.K./	1	US 6,680,568 B2	01/20/2004	Fujiwara et al.			
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/B.K./	2	US 2002/0105266 A1	08/08/2002	Juestel et al.			
<b>FOREIGN PATENT DOCUMENTS</b>							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
							YES
/B.K./	3	CN 1366714 A	02/11/2005	CHINA			✓
/B.K./	4	CN 1349262 A		CHINA			✓
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
/B.K./		Chinese Office Action dated February 2, 2007 with partial English translation.					
EXAMINER				DATE CONSIDERED		04/19/2007	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							